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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Takahiro HORIGUCHI, et al.

SERIAL NUMBER: 09/855,493

GROUP: 1763

FILED: May 16, 2001

EXAMINER: KACKAR, RAM N

FOR: SINGLE-SUBSTRATE-PROCESSING APPARATUS FOR SEMICONDUCTOR  
PROCESS

**REQUEST TO CORRECT TITLE OF INVENTION**

MAIL STOP ISSUE FEE  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application for patent, we hereby request  
correction of your records to reflect the correct title of the invention. The title of the  
invention should read as follows: SINGLE-SUBSTRATE-PROCESSING APPARATUS  
FOR SEMICONDUCTOR PROCESS.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

  
Marvin J. Spivak

Attorney of Record  
Registration No. 24,913

Joseph A. Scafetta, Jr.  
Registration No. 26,803

Customer Number

**22850**

Tel.: (703) 413-3000  
Fax: (703) 413-2220  
(OSMMN 08/03)